


REMARKS

By this Preliminary Amendment, minor changes have been made to the specification.

Entry of this Preliminary Amendment is respectfully requested.

Respectfully submitted,

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ATTACHMENT "A"

Additions/Deletions to the Specification:

Page 10, lines 9-11:

FIG. 14 is a top [~~longitudinal sectional~~] view of a still further embodiment of semiconductor device manufacturing equipment having a robot that includes a branched wafer support according to the present invention.

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